

301
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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

3c/702

APPL. NUM 100-4351	FILING DATE 12/21/2001	CLASS 438	SUBCLASS 745	GAU 1765	EXAMINER Rafael Ramos
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CONTINUING DATA VERIFIED:

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FOR IN APPLICATIONS VERIFIED:

JAPAN 2000-393318 12/25/2000

PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed

☐ yes ☐ no

35 USC 119 conditions met

☐ yes ☐ no

Identified and Acknowledged Examiners' initials

ATTORNEY DOCKET NO.

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Title: Method of manufacturing semiconductor device and method of manufacturing optical wave guide

U.S. DEPT. OF COMM. PAT. & TRADEMARK (Rev. 12-51)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
ISSUE FEE		Assistant Examiner	
Amount Due	Date Paid	Primary Examiner	
TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
		Application Examiner	
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